

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: K. INOUE et al.
Serial No.: (New Divisional application under 37 CFR §1.53[b] of U.S.
Application Serial No. 09/698,186)
Filed: On Even Date Herewith
For: SEMICONDUCTOR DEVICE AND METHOD FOR
PRODUCING THE SAME
Group: 2811
Examiner: D. OWENS

CLAIM FOR FOREIGN PRIORITY

MS: PATENT APPLICATIONS

Commissioner for Patents
POB 1450
Alexandria, VA 22313-1450

April 16, 2004

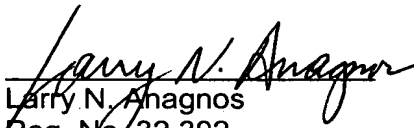
Sir:

Pursuant to 35 U.S.C. §119 and 37 CFR §1.55, applicants hereby claim
the right of priority based on the following foreign applications filed in Japan:

Application No. 11-307986, filed October 29, 1999.
Application No. 2000-134209, filed April 28, 2000.
Application No. 2000-134210, filed April 28, 2000.
Application No. 2000-134211, filed April 28, 2000.

Certified copies of these foreign applications were filed on November 28,
2000 in prior, U.S. parent application Serial No. 09/698,186, filed October 30,
2000.

Respectfully submitted,
ANTONELLI, TERRY, STOUT & KRAUS, LLP


Larry N. Anagnos
Reg. No. 32,392

LNA:dk
(703) 312-6600